



**PATENT**  
Attorney Docket No. 402769/ASAHINA  
Client Reference No. FP-8468

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Yoshiharu TAKAHASHI

Application No. 10/663,940

Filed: September 17, 2003

For: **METHOD OF MAKING  
SEMICONDUCTOR DEVICE**

Allowed: March 31, 2004

Confirmation No.: 3859

Art Unit: 2818

Examiner: Dao H. NGUYEN

**SUBMISSION OF FORMAL DRAWINGS**

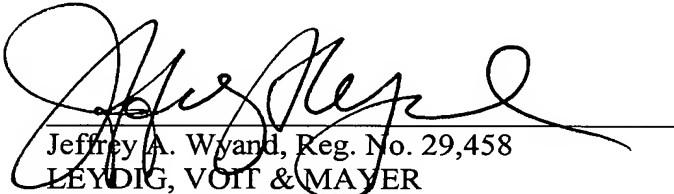
U.S. Patent and Trademark Office  
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Commissioner for Patents  
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Attn: Official Draftsman

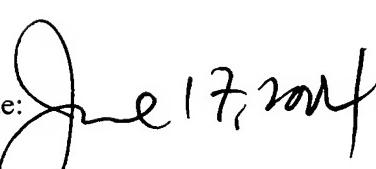
Dear Sir:

Applicant encloses herewith 12 sheets of formal drawings and requests that the same be made of record in this application as a substitute for the informal drawings filed with the application on September 17, 2003.

Respectfully submitted,



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Drawings - Formal (Revised 6/5/04)